

PATENT APPLICATION —

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)	
	:	Examiner: M. Padgett
TAKESHI SHISHIDO ET AL.)	
	:	Group Art Unit: 1762
Application No.: 09/822,191)	
	:	
Filed: April 2, 2001)	
	:	
For: EXHAUST PROCESSING METHOD,	,)	
PLASMA PROCESSING METHOD	:	
AND PLASMA PROCESSING)	
APPARATUS	:	April 26, 2006

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

SUBMISSION UNDER 37 C.F.R. §1.114

Sir:

(a) <u>Introductory Comments</u>

In response to the final Office Action dated December 29, 2005, kindly amend the subject application as follows.